

**Application Data Sheet****Applicant Information**

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Junichi
Family Name::	UENO
City of Residence::	Fukushima
Country of Residence::	JAPAN

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**Correspondence Information**

Correspondence Customer Number::	25944
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**Application Information**

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R::	None
Title::	WAFER-HOLDING CARRIER, DOUBLE-SIDE POLISHING APPARATUS USING THE SAME, AND DOUBLE-SIDE POLISHING METHOD OF WAFER
Attorney Docket Number::	125333
Suggested Drawing Figure::	
Total Drawing Sheets::	5
Small Entity::	No

**Representative Information**

James A. Oliff, Reg. No. 27,075	William P. Berridge, Reg. No. 30,024
Thomas J. Pardini, Reg. No. 30,411	Edward P. Walker, Reg. No. 31,450
Robert A. Miller, Reg. No. 32,771	Mario A. Costantino, Reg. No. 33,565
Kirk M. Hudson, Reg. NO. 27,562	

<b>Domestic Priority Information</b>			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP04/003335	3/12/04
<b>Foreign Priority Information</b>			
Country::	Application Number::	Filing Date::	Priority Claimed::
JAPAN	2003-77272	3/20/03	Yes
<b>Assignee Information</b>			
Assignee Name::		SHIN-ETSU HANDOTAI CO., LTD.	
Street of mailing address::		4-2, Marunouchi 1-chome,	
City of mailing address::		Chiyoda-ku,	
State or Province of mailing address::		Tokyo,	
Country of mailing address::		JAPAN	